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Application/Control No.	Applicant(s)/Patent under Reexamination	
10/532,196	JANG ET AL.	
Examiner	Art Unit	
Yong Chu	1626	

	SEAR	CHED	
Class	Subclass	Date	Examiner
514	283	9/7/2006	YC
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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See sera	ich report		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	
STN	9/6/20	06 YC
EAST	9/7/20	06 YC
PALM	9/7/20	06 YC
Google	9/7/20	106 YC